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PATENT & TRADEMARK OFFICE

Attorney's Docket No.: 042390P3955D

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
Andideh, Ebrahim et al.)
U.S. Serial No: 09/436,092) Examiner: McDonald, Shantese L.
Filed: November 8, 1999) Art Unit: 3723
For: POLISH PAD WITH)
NON-UNIFORM GROOVE DEPTH)
TO IMPROVE WAFER POLISH RATE)
UNIFORMITY)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action that was mailed on March 11, 2005. Applicants respectfully request the Examiner to enter the following amendments and consider the remarks therein.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

on March 17, 2005 Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

Teresa Mattox

Signature

March 17, 2005

Date